

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: Application of Kubota et al.
Serial No.: To be Assigned
Filed: Concurrently Herewith
For: **RESIST MATERIAL AND METHOD
FOR PATTERN FORMATION**

*J. A.
D. G.
8-28-01*

Date: May 8, 2001

BOX PATENT APPLICATION
Commissioner for Patents
Washington, DC 20231

PRELIMINARY AMENDMENT

Sir:

Prior to the examination of the above application, please amend the above-identified application as follows. Attached hereto is a marked up version of the changes made to the claims by the current amendment. The marked up version of the changes to the claims is captioned "Version With Markings To Show Changes Made".

In the Specification:

Please insert the following text on page 1, line 1:

- Cross-Reference to Related Applications

The present application claims priority to Japanese Patent Application No. 2000-139537 filed May 12, 2000, the disclosure of which is incorporated herein by reference in its entirety. -

In the Claims:

Please delete Claims 5-8 for the purposes of rewriting.

Please insert the following new claims.

9. A resist material according to claim 1 wherein said or more surfactants having a fluorine substituent is selected from the group consisting of perfluoroalkylpolyoxyethylene ethanol, fluorinated alkyl ester,

X J.W.C.